

East 3 USPB USPT

L Number	Hits	Search Text	DB	Time stamp
1	58848	backside? or (back with side?)	USPAT; US-PGPUB	2004/04/26 15:12
2	92708	frontside? or (front with side?)	USPAT; US-PGPUB	2004/04/26 15:12
3	425645	wafer? or semiconductor? or substrate? or chip?	USPAT; US-PGPUB	2004/04/26 15:12
4	392	((backside? or (back with side?)) same (frontside? or (front with side?)) same (wafer? or semiconductor? or substrate? or chip?))	USPAT; US-PGPUB	2004/04/26 15:12
5	57	((backside? or (back with side?)) same (frontside? or (front with side?)) same (wafer? or semiconductor? or substrate? or chip?)) same (cmp or polish\$ or chemipolish\$ or chemimech\$ or planariz\$ or lap\$ or grind\$ or abrad\$)	USPAT; US-PGPUB	2004/04/26 15:13
7	32	((((backside? or (back with side?)) same (frontside? or (front with side?)) same (wafer? or semiconductor? or substrate? or chip?)) same (cmp or polish\$ or chemipolish\$ or chemimech\$ or planariz\$ or lap\$ or grind\$ or abrad\$)) same (detect\$ or measur\$ or analy\$ or defect\$ or emission or support\$ or protect\$ or bond\$ or adhes\$ or adher\$ or bow\$ or warp\$)	USPAT; US-PGPUB	2004/04/26 15:16
8	25	((((backside? or (back with side?)) same (frontside? or (front with side?)) same (wafer? or semiconductor? or substrate? or chip?)) same (cmp or polish\$ or chemipolish\$ or chemimech\$ or planariz\$ or lap\$ or grind\$ or abrad\$)) not (((backside? or (back with side?)) same (frontside? or (front with side?)) same (wafer? or semiconductor? or substrate? or chip?)) same (cmp or polish\$ or chemipolish\$ or chemimech\$ or planariz\$ or lap\$ or grind\$ or abrad\$)) same (detect\$ or measur\$ or analy\$ or defect\$ or emission or support\$ or protect\$ or bond\$ or adhes\$ or adher\$ or bow\$ or warp\$))	USPAT; US-PGPUB	2004/04/26 15:16

East & USPB, USPT

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1	25	(((((backside? or (back with side?)) same (frontside? or (front with side?)) same (wafer? or semiconductor? or substrate? or chip?)) same (cmp or polish\$ or chemipolish\$ or chemimech\$ or planariz\$ or lap\$ or grind\$ or abrad\$)) not (((backside? or (back with side?)) same (frontside? or (front with side?)) same (wafer? or semiconductor? or substrate? or chip?)) same (cmp or polish\$ or chemipolish\$ or chemimech\$ or planariz\$ or lap\$ or grind\$ or abrad\$)) same (detect\$ or measur\$ or analy\$ or defect\$ or emission or support\$ or protect\$ or bond\$ or adhes\$ or adher\$ or bow\$ or warp\$))	USPAT; US-PGPUB	2004/04/26 15:31